INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

October 31, 2025

IGI Report Number	LG744504272
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	RECTANGULAR CUSHION MIXED CUT
Measurements	11.76 X 7.64 X 4.87 MM

GRADING RESULTS

Carat Weight	4.04 CARATS
Color Grade	E
Clarity Grade	VS 1

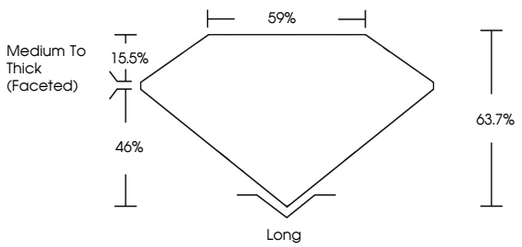
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG744504272

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG744504272
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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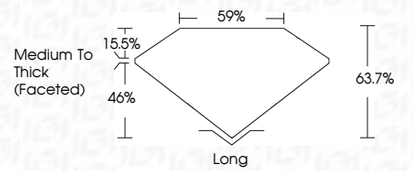
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IGI

October 31, 2025
IGI Report No LG744504272
RECTANGULAR CUSHION MIXED CUT
11.76 X 7.64 X 4.87 MM
Carat Weight 4.04 CARATS
Color Grade E
Clarity Grade VS 1
Depth 63.7%
Table 59%
Girdle Medium To Thick (Faceted)
Culet Long
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) LG744504272
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa